



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 6, 2025	
IGI Report Number	LG754558635
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PRINCESS CUT
Measurements	6.20 X 6.19 X 4.52 MM

GRADING RESULTS

Carat Weight	1.47 CARAT
Color Grade	F
Clarity Grade	VS 1

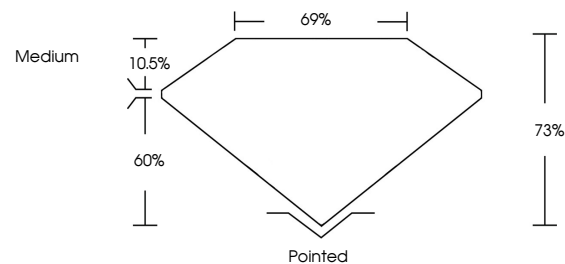
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG754558635

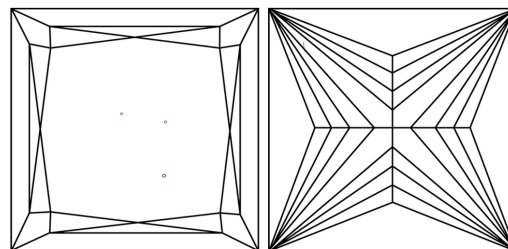
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG754558635
Report verification at igi.org

PROPORTIONS

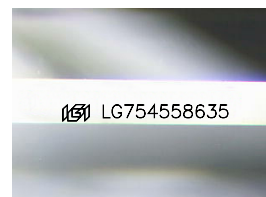


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

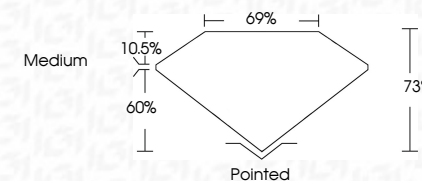
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www.igi.org

December 6, 2025
 IGI Report No LG754558635
 PRINCESS CITT

1.47 CARAT F	VS 1	73%	69%	Medium	Pointed	EXCELLENT	EXCELLENT	NONE	None
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